As a below named inventor, I declare that my residence, mailing address and citizenship are as stated below that y name; I believe that I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural names are listed below) of the subject matter which is claimed and for which a patent is sought on the invention entitled:

SEMICONDUCTOR MEMORY INCLUDING STATIC RANDOM ACCESS MEMORY FORMED OF FINFET

the specification	of which (check aj	pplicable box(es))		
[] is attached	hereto.			
[X] was filed on	March 18, 20	on as United Stat	es Application No. 10/802	,799
or PCT Inte	rnational Applicat	ion No.		
[] and was am	ended on			
I hereby state th	at I have reviewed	d and understand the content	s of the aboveidentified spec	ification, including
the claims, as an	nended by any am	endment referred to above.		
I acknowledge t	he duty to disclose	information which is materia	l to patentability as defined	in 37 CFR 1.56.
I hereby claim fe	oreign priority ben	efits under 35 U.S.C. 119(a)-(d) or 365(b) of any foreign a	pplication(s) for
patent or invent	or's certificate, or	35 U.S.C. 365(a) of any PCT I	nternational application wh	ich designated at
least one countr	y other than the U	nited States, listed below and	l have also identified below :	any foreign
application for p	atent or inventor's	certificate, or PCT Internation	onal application having a fili	ing date before that
of the applicatio	n on which priority	y is claimed:		
				Priority
Country	Category	Application Number	Filing Date	Claim
Japan	Patent	2003-375851	November 5, 2003	Yes

I hereby appoint as my attorneys, with full power of substitution and revocation, to prosecute this application and transact all business in the Patent and Trademark Office connected therewith: the practitioners at:

Customer Number: 22850

of Oblon, Spivak, McClelland, Maier & Neustadt, P.C.. Please address all correspondence and telephone communications to the address and telephone number for this Customer Number.

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

I declare further that my citizenship, residence and ma	ailing address are as stated below next to my name:
[1st Inventor] Residence Address: Yokohama-shi, Japan Mailing Address: c/o Intellectual Property Division, To Minato-ku, Tokyo 105-8001, Japan Citizenship: Japan	oshiba Corporation, 1-1, Shibaura 1-chome,
Jakeshi Watanabe Takeshi Watanabe	APR. 1 4. 2004
Takeshi Watanabe	Date:
[2nd Inventor] Residence Address: Yokohama-shi, Japan Mailing Address: c/o Intellectual Property Division, To Minato-ku, Tokyo 105-8001, Japan Citizenship: Japan	oshiba Corporation, 1-1, Shibaura 1-chome,

Date:

APR. 1 4. 2004